



500.40410VX1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Nobuyuki MISE, et al.
Application No.: 10/697,326
Filed: October 31, 2003
For: ION CURRENT DENSITY MEASURING METHOD
AND INSTRUMENT, AND SEMICONDUCTOR
DEVICE MANUFACTURING METHOD
Art Unit: 2829
Examiner: Unknown

INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR §§ 1.97 & 1.98

Mail Stop DD
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

April 14, 2004

Sir:

In the matter of the above-identified application, applicants are submitting herewith a copy of the documents listed in the attached form PTO/SB/08A for the Examiner's consideration.

This Information Disclosure Statement is being submitted before the mailing date of a first office action on the merits.

To the extent the documents listed on the attached form PTO/SB/08A are not in the English language, the requirement of 37 CFR '1.98(a)(3) for a concise explanation of the relevance is satisfied by an English language translation of the abstract of the non-English listed documents. It is respectfully requested that this Information Disclosure Statement be considered by the Examiner.

Application No.: 10/697,326

Docket No.: 500.40410VX1

Please charge any shortage in the fees due in connection with the filing of this paper, including extension of time fees, to the deposit account of Antonelli, Terry, Stout & Kraus, LLP, Deposit Account No. 01-2135 (Docket No. 500.40410VX1) please credit any excess fees to such deposit account.

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP

By

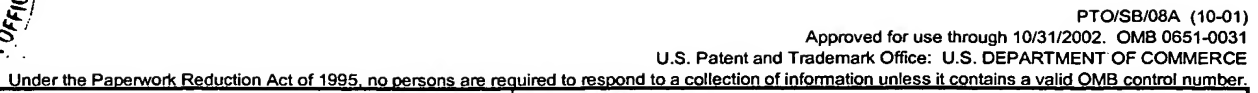


Gregory E. Montone

Reg. No. 28,141

GEM/dmw/dlt

1300 North Seventeenth Street, Suite 1800
Arlington, Virginia 22209
Telephone: (703) 312-6600
Facsimile: (703) 312-6666



INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Sheet

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of

1

Application Number

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First Named Inventor

Nobuyuki MISE, et al.

Art Unit

2829

Examiner Name

Unknown

Attorney Docket Number

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Examiner Initials ¹	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ^a
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)				
		JP9266199	10-07-1997	Hitachi, Ltd.		Abst
		JP3086731	04-11-1991	Toyoda Gosei Co., Ltd		Abst

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
		Japanese Office Action and Search Report dated February 28, 2004	

Date
Considered

¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard St.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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